

UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Vignia 22313-1450 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 3456

SERIAL NUMBI 10/502,389	FILING OR 371(c) DATE 10/502,389 FILING OR 371(c) DATE 07/26/2004 RULE		CLASS 438		GROUP ART UNIT 2812			ATTORNEY DOCKET NO. 120503	
Tatsuo Ito, Tokyo, JAPAN; Shigeyoshi Netsu, Fukushima, JAPAN; Masashi Ichikawa, Fukushima, JAPAN; Nobuhiro Ohara, Fukushima, JAPAN; ***********************************									
Foreign Priority claimed 35 USC 119 (a-d) conditions yes no Met after Allowance Verified and Acknowledged Examiner's Signature Initials ADDRESS				STATE OR COUNTRY JAPAN			TOTA CLAI 35	MS	INDEPENDENT CLAIMS 3
25944									
TITLE Semiconductor wafer manufacturing method, semiconductor wafer mnaufacturing order acceptance method, and semiconductor wafer manufacturing order acceptance system									
FILING FEE F	EE FEES: Authority has been given in Paper					☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			